

**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 1792**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Jin Zhao et al. Confirmation No.: 4854  
Application Number : 10/623,757  
Filed : July 21, 2003  
Title : MAINTAINING A REACTOR CHAMBER OF A CHEMICAL  
VAPOR DEPOSITION SYSTEM  
TC/Art Unit : 1792  
Examiner: : Francis P. Smith  
  
Docket No. : TI-35855 (0025.0220)  
Customer No. : 23494

OK to  
enter  
C. Quen  
7/16/08

**MAIL STOP AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Responsive to the Final Office Action mailed June 12, 2008, and pursuant to  
37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks** follow the amendments section of this paper.